

Transaction Information

Tool ID	LATK762
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2024-05-06

General Product Information

Vendor Supplier	TOKYO ELECTRON LIMITED
Model	LITHIUS I+
Vintage	2008
Serial No	G481358
Asset Description	TEL LITHIUS I+ ARF IMMERSION TRACK
Software Version	300.0.71.3
CIM	SECS
Process	ARF IMMERSION

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	PIR	2	OK
Main System	CPHP	16	OK
Main System	Main Tool	1	OK
Main System	ITC	3	OK
Main System	BCT	2	OK
Main System	EPHP	7	OK
Handler System	IRAI	1	OK
Handler System	IRAM	1	OK
Handler System	MPA	1	OK
Options System			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
AC Power Box	1	OK
DEV Chemical Cabinet	1	OK
T&H Controller	2	OK
COT Chemical Cabinet	1	OK

Missing/Faulty Parts / Accesories List

Description	Quantity
None	

Hardware Fab

Hardware Config (Fab)



Hardware Fab

Hardware Config (Fab)





Hardware Sub-fab

Hardware Config (Sub-Fab)



Hardware Sub-fab

Hardware Config (Sub-Fab)







Hardware Sub-fab

Hardware Config (Sub-Fab)



Manufacture Serial

Machine Serial Number

